

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant :	Eiji Nishibe et al.	Art Unit :	2812
Serial No. :	10/809,011	Examiner :	Walter Lee Lindsay, Jr.
Filed :	March 25, 2004	Conf. No. :	7829
Title :	MANUFACTURING METHOD FOR A SEMICONDUCTOR DEVICE WITH REDUCED LOCAL CURRENT		

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF SEPTEMBER 20, 2006

Please amend the above-identified application as follows: